



Corres. and Mail
BOX AF

61

AF 1700

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE - EXAMINING GROUP 1700

PATENT

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

September 9, 2003
Date

Denise Sheridan
Denise Sheridan

RECEIVED
SEP 11 2003
TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 09/970,100 Confirmation No. : 2699
Applicants : Vishnu K. Agarwal et al. Attorney Docket No.: 500453.04 (29113/US/3)
Filed : October 2, 2001 Customer No. : 27,076
Art Unit : 1762 ✓
Examiner : William P. Fletcher III
Title : POLISHING PADS AND PLANARIZING MACHINES FOR MECHANICAL OR
CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE
SUBSTRATE ASSEMBLIES, AND METHODS FOR MAKING AND USING SUCH
PADS AND MACHINES

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Do not enter.
WPF 09/17/03.

RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

Applicant acknowledge receipt of the Office Action dated June 23, 2003.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 7 of this paper and include both attached replacement sheets and annotated sheets showing changes.

Remarks begin on page 8 of this paper.

An Appendix including amended drawing figures is attached following page 11 of this paper.